

85A 3050

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

SHIGERU HAYATA et al.

Serial No: 09/800,323

Filed: March 6, 2001

For: OFFSET MEASUREMENT  
METHOD, TOOL POSITION  
DETECTION METHOD AND  
BONDING APPARATUS

Art Unit: 2877

Examiner: Hoa Q. Pham

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FEB 04 2004

**OFFICIAL**RULE 116 AMENDMENTCommissioner for Patents  
P.O. Box 1450  
Alexandria VA 22313-1450

Dear Sir:

In response to the Final Office Action dated January 2, 2004, please amend the above-identified application as follows: